



Attorney Docket No: SEL 194

UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Suzawa et al.

Serial No.: 09/615,449

Filed: July 13, 2000

For: Wiring And Manufacturing Method Thereof,  
Semiconductor Device Comprising Said  
Wiring, And Dry Etching Method

Examiner: H. Trinh

Art Unit: 2814

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Signature Shannon Wallace

Date 12/3/04

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**AMENDMENT (F)**

In response to the Office Action dated September 9, 2004 and the interview summary of November 18, 2004, please amend the above-identified application as follows: